


Form PTO-1449	U.S. Dept. of Commerce Patent & Trademark Office	Atty. Docket: 00-GR1-408	Serial No.: 10/044,286
List of Documents Cited by Applicant (Use several sheets if necessary)		Applicant: Olivier MENUT et al.	
		Filing Date: January 11, 2002	Group: 2814

U.S. PATENT DOCUMENTS							
Ex'r's Init	Document Number	Date	Name	Class	Sub- class	Filing Date, if applicable	
AA1	5,307,169	April 26, 1994	Nagasaki et al.				

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Sub- class	Transl'n Yes/No	
AA2	WO99/48152	September 23, 1999	PCT			Yes	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
AA3	"One-Device CMOS Dram Cell with Buried Poly Trench and Drain Reach Through," IBM Technical Disclosure Bulletin, pp. 451-452, Vol. 30, No. 11, April 1988.	
AA4	"Vertical Conducting Connection to a Poly-Si Trench In Si," IBM Technical Disclosure Bulletin, pp. 310-312, Vol. 31, No. 12, May 1989.	
AA5	Preliminary Search Report dated October 19, 2001 for French Patent Application No. 0100420.	

Examiner: 	Date Considered: 8/15/05
-----------------------------------------------------------------------------------------------	--------------------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.